Se	earch l	Notes	

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/772,323	SATOMI ET AL.	
Examiner	Art Unit	
Eric Wendler	2824	

SEARCHED			
Class	Subclass	Date	Examiner
365	149	1/26/2006	EJW
365	102	1/26/2006	EJW
307	109	1/26/2006	EJW
365	189.11	1/26/2006	EJW
365	204	1/26/2006	EJW
365	230.06	1/26/2006	EJW
365	185.23	1/26/2006	EJW
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INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
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	DATE	EXMR
See updated EAST search history	1/26/2006	EJW
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